

Phonon Collection Modeling in G4CMP with Finite Surface Losses

Toward Direct Absorber Phonon Sensor Design

Selby Q Dang / SLAC + Stanford

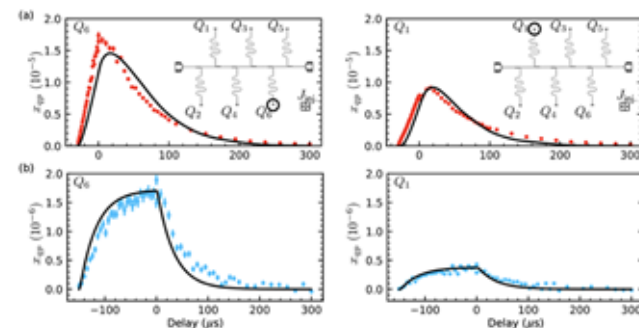
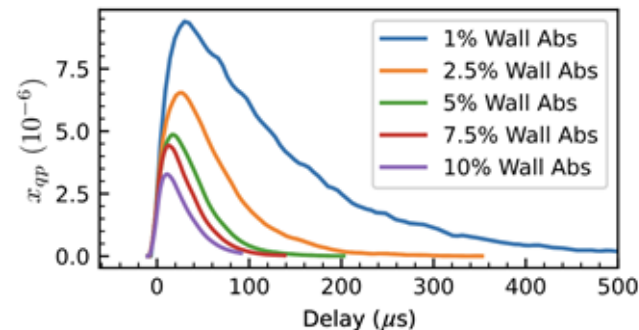
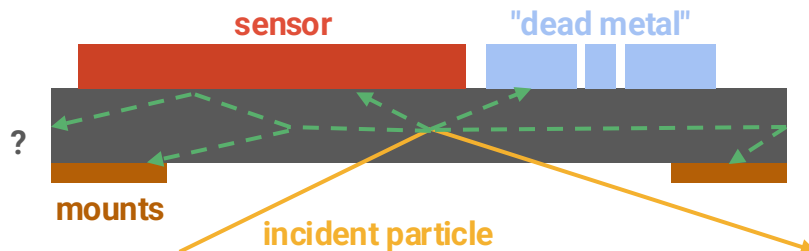
June 15, 2026 | RISQ 2026 G4CMP Workshop



Overview

Benchmarking effects of phonon loss is relevant for modeling diverse phonon sensors in G4CMP.

- Evidence for phonon thermalization in cryogenic crystals is not fully modeled by anharmonic decay or loss to device clamps
- Position-dependent phonon responsivity gives insight into loss mechanisms
- Using one possible loss model, we can optimize sensor layout for efficiency



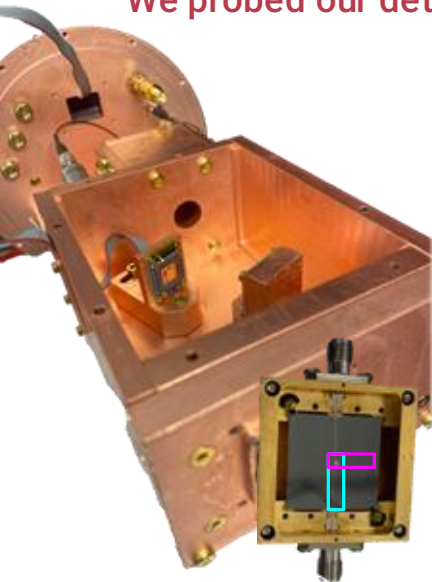
<https://journals.aps.org/prb/pdf/10.1103/PhysRevB.10.024519>

Part I

Benchmarking Phonon Loss

MEMS Measurement

We probed our detector response to LED pulses at different XY positions using the MEMS.



Our KIPM detector:

- MKID as phonon sensor
- Direct absorber: no trapping
- Small sensor (<0.1% coverage on Si substrate)
- Thin film (30 nm Al)
- Single resonator

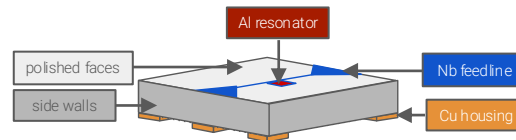


Image credit: Leonid Sajkov

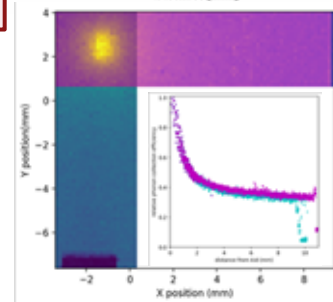
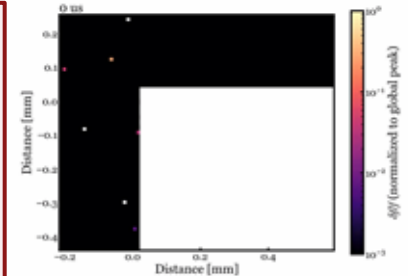


Image credit: Zoë Smith

Journal of Optical Microsystems, Vol. 5, Issue 2, 024503 (June 2025).
<https://doi.org/10.1117/1.JOM.5.2.024503>

<https://custom.cvent.com/B6DBF01384AB4E1CB4B0C6F97B77BD82/files/event/22930724c2e84b3b93f62c7170746141/47687c07935646a0acea1924d0112ab4.pdf>

Characterizing Position-Dependent Phonon Efficiency in KIPM Detectors Using Cryogenic MEMs Mirrors

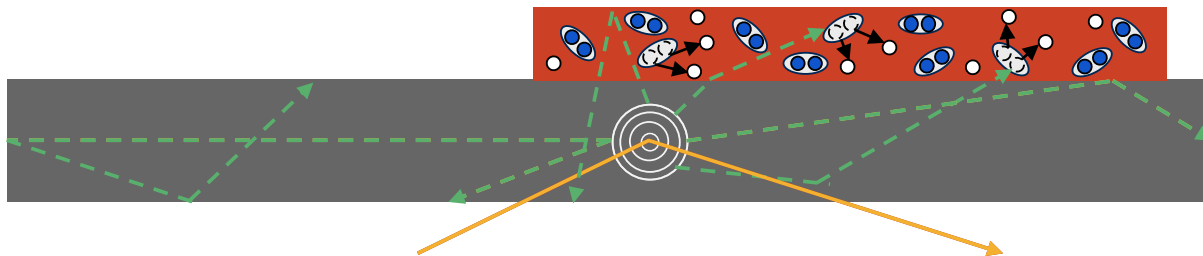
Z.J. Smith^{1,2}, Z. Ahmed^{2,3}, T. Aralis^{2,3}, S. Golwala⁴, S.W. Henderson^{2,3}, H. Magoon^{2,4}, A. Nuñez⁴, E. Panner⁵, G. Pérez⁴, B. Sandoval⁵, S. Stevens³, N. Tabassum², D. Temples⁷, O. Wen^{2,3}, R. Junwen Xiong⁵, B.A. Young⁶, and N.A. Kurinsky^{1,2,3}

Development Status of the KIPM Detector Consortium

Dylan J Temples⁷, Zoë J. Smith, Selby Q Dang⁷, Taylor Aralis, Chi Cap⁷, Clarence Chang⁷, Yen-Yung Chang, Maurice Garcia-Sciveres, Sunil Golwala⁴, William Ho, Noah Kurinsky⁷, Kungang Li, Xiran Li, Marharyta Lisovenko⁷, Elizabeth Panner, Karthik Ramanathan⁷, Shilin Ray, Brandon Sandoval, Aritoki Suzuki⁷, Gensheng Wang⁷, Osmond Wes, Michael Williams, Junwen Robin Xiong, and Volodymyr Yefremenko⁷

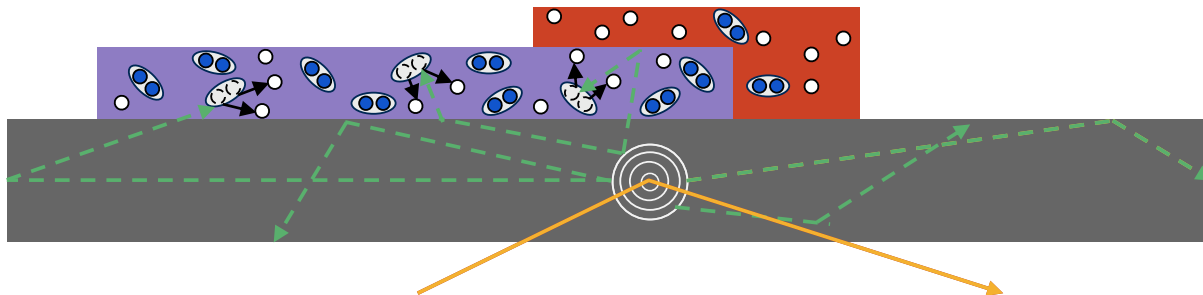
Direct Absorber Architecture

In our detector, phonons are directly absorbed into the MKID inductor, which generates the signal.
Direct absorber (e.g. KIPM):



- Incident Particle
- Cooper Pair
- Quasiparticle
- - - Athermal Phonon
- Crystalline Substrate
- Sensitive Volume
- Collector Volume

Quasiparticle trapping (e.g. QET, SQUAT):



**Analysis of Event Position Dependence
in HVeV Detectors with G4CMP and
MEMS**

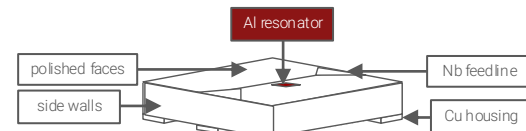
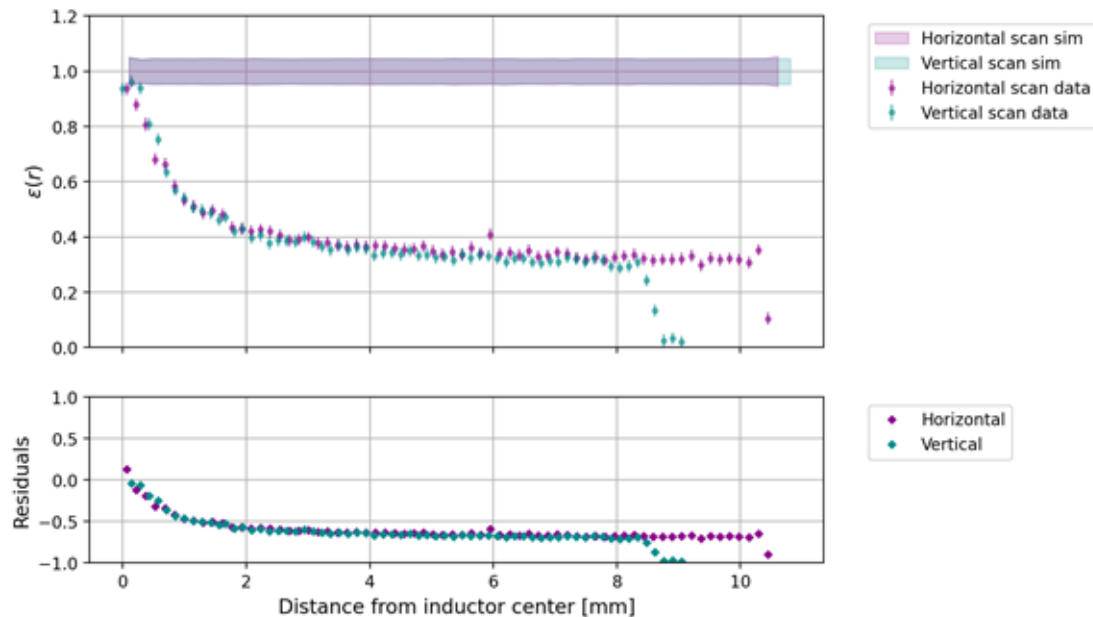
Caitlyn Stone-Whitehead
6/15, 10:20 am

**SQUATs: Qubit-Based Sensors for
Dark Matter**

Hannah Magoon
6/18, 10:00 am

From Phonon Loss to Position Dependence

Loss mechanisms differently affect position dependence in phonon collection efficiency.

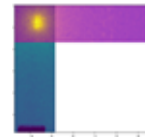


$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0
$P_{\text{abs, Cu}}$	0
$P_{\text{abs, polished surfaces}}$	0
$P_{\text{abs, side walls}}$	0

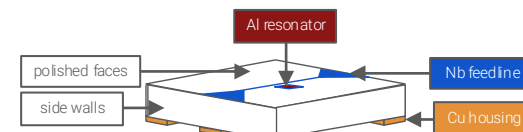
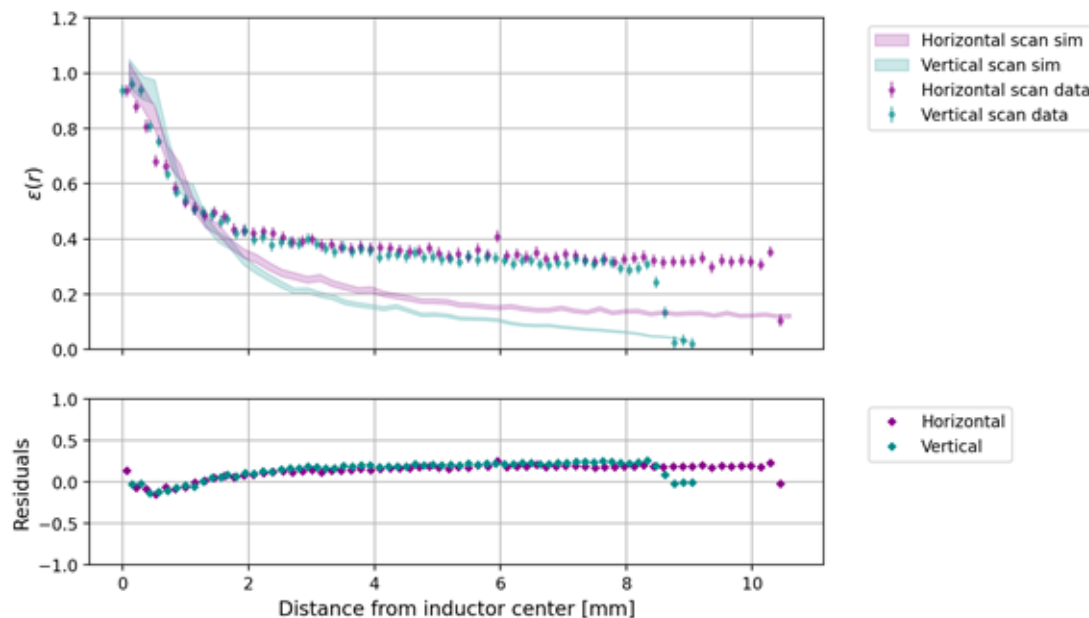
η : absolute phonon energy collection efficiency

ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

From Phonon Loss to Position Dependence



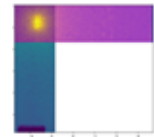
Loss mechanisms differently affect position dependence in phonon collection efficiency.



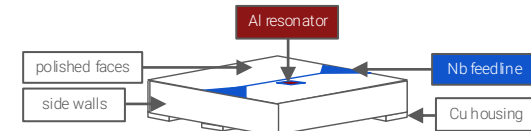
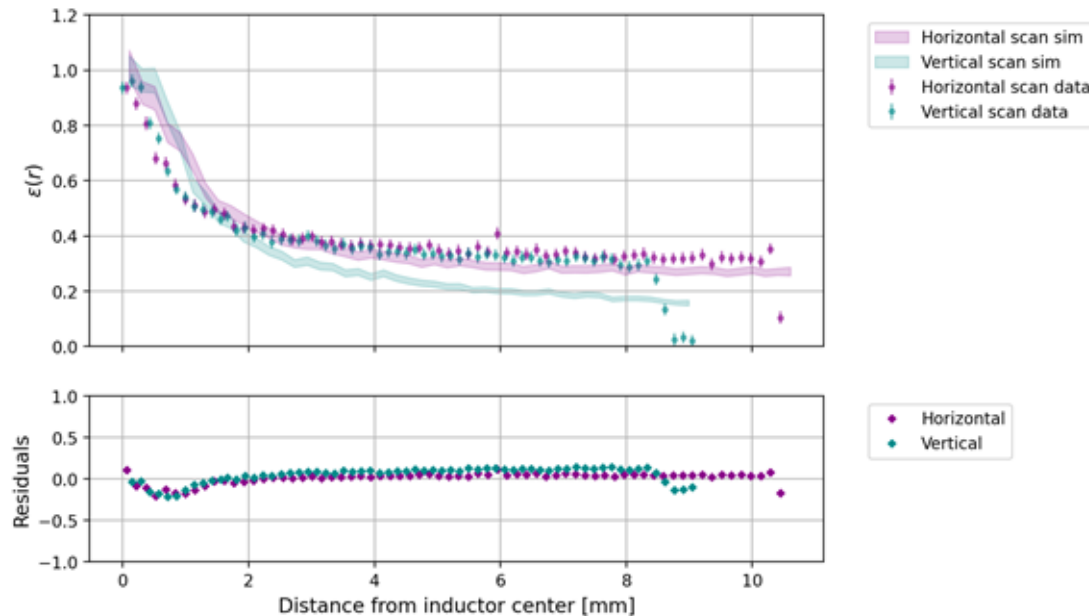
$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0.745
$P_{\text{abs, Cu}}$	0.736
$P_{\text{abs, polished surfaces}}$	0
$P_{\text{abs, side walls}}$	0

η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

From Phonon Loss to Position Dependence



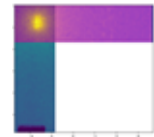
Loss mechanisms differently affect position dependence in phonon collection efficiency.



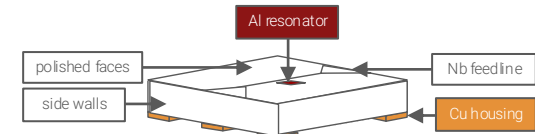
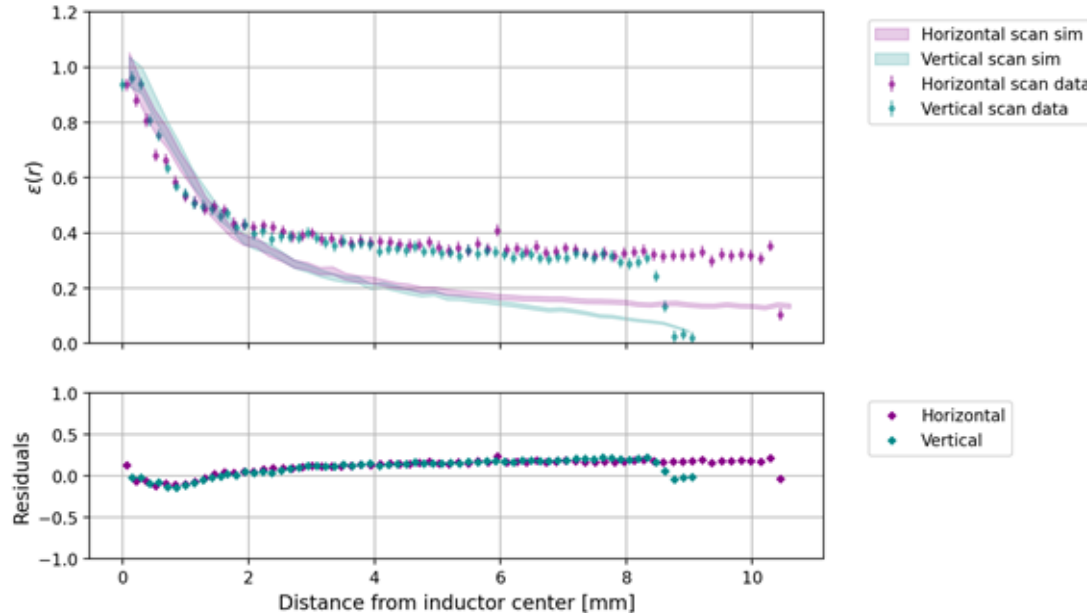
$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0.745
$P_{\text{abs, Cu}}$	0
$P_{\text{abs, polished surfaces}}$	0
$P_{\text{abs, side walls}}$	0

η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

From Phonon Loss to Position Dependence



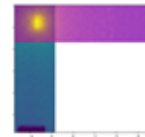
Loss mechanisms differently affect position dependence in phonon collection efficiency.



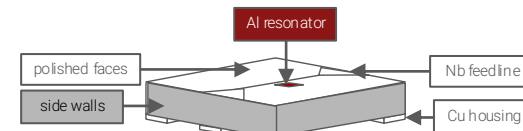
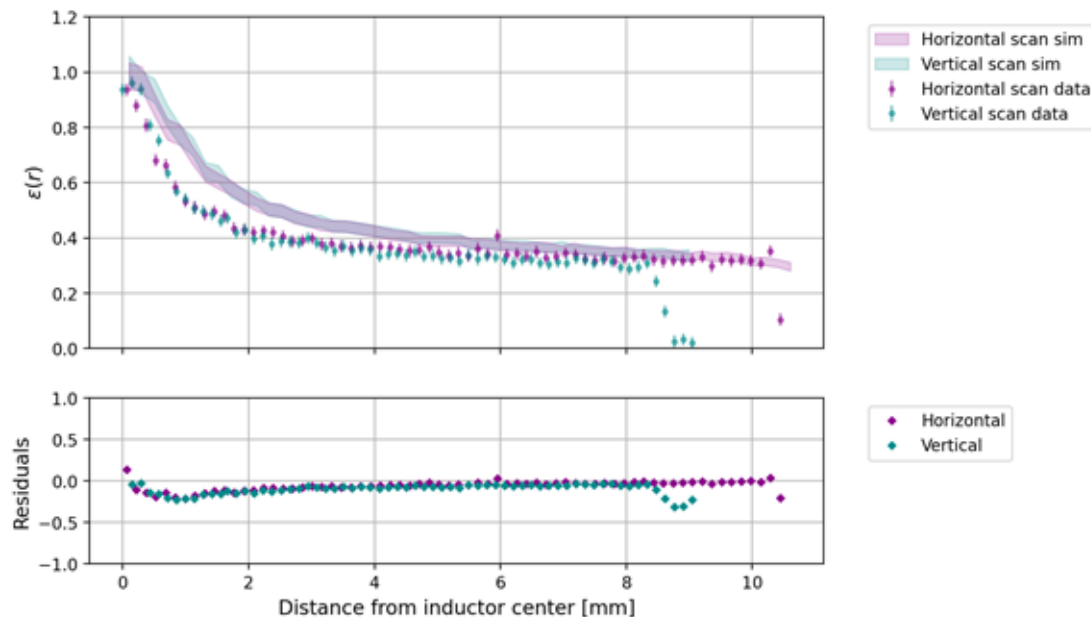
$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0
$P_{\text{abs, Cu}}$	0.736
$P_{\text{abs, polished surfaces}}$	0
$P_{\text{abs, side walls}}$	0

η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

From Phonon Loss to Position Dependence



Loss mechanisms differently affect position dependence in phonon collection efficiency.

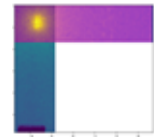


$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0
$P_{\text{abs, Cu}}$	0
$P_{\text{abs, polished surfaces}}$	0
$P_{\text{abs, side walls}}$	0.025

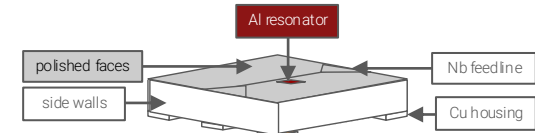
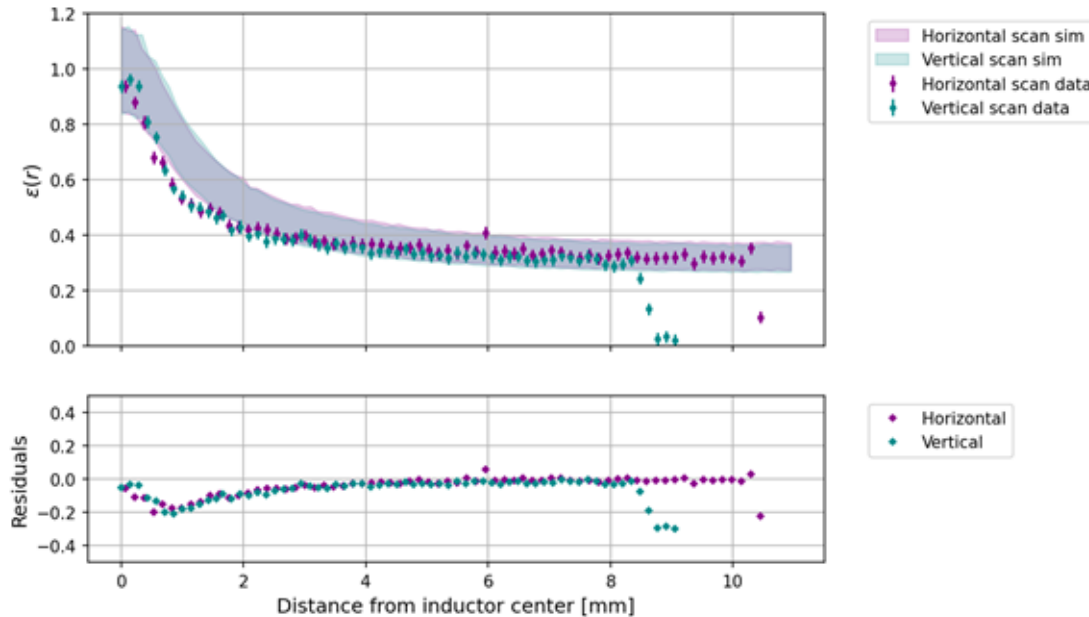
η : absolute phonon energy collection efficiency

ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

From Phonon Loss to Position Dependence



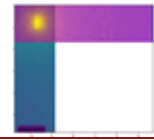
Loss mechanisms differently affect position dependence in phonon collection efficiency.



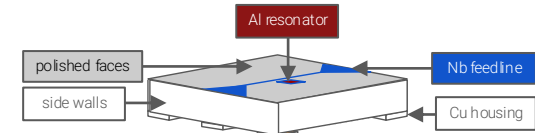
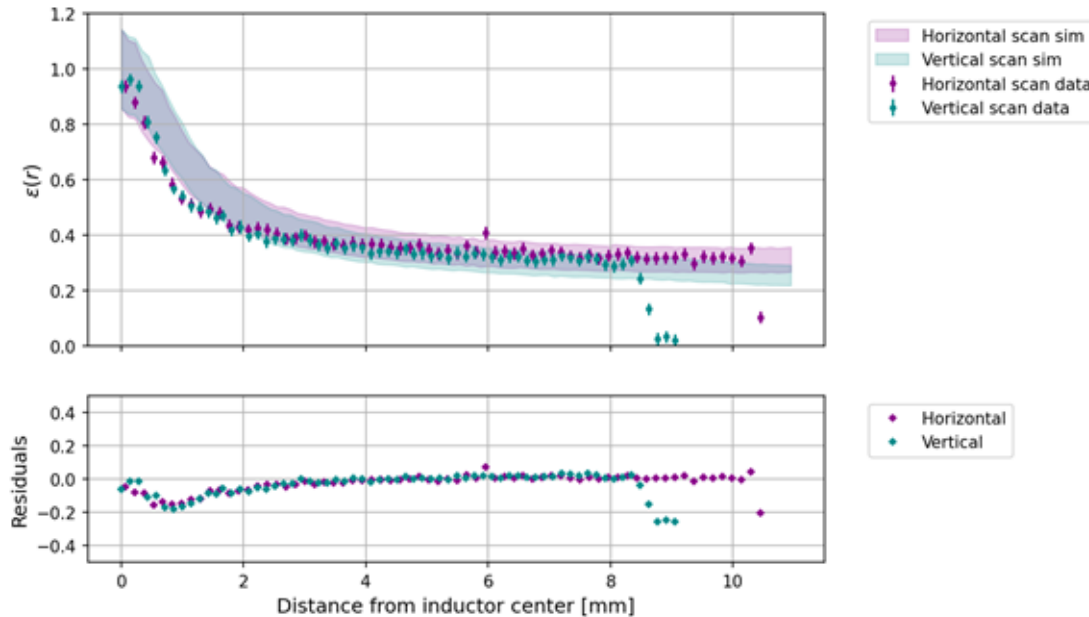
$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0
$P_{\text{abs, Cu}}$	0
$P_{\text{abs, polished surfaces}}$	0.0025
$P_{\text{abs, side walls}}$	0

η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

From Phonon Loss to Position Dependence



Loss mechanisms differently affect position dependence in phonon collection efficiency.

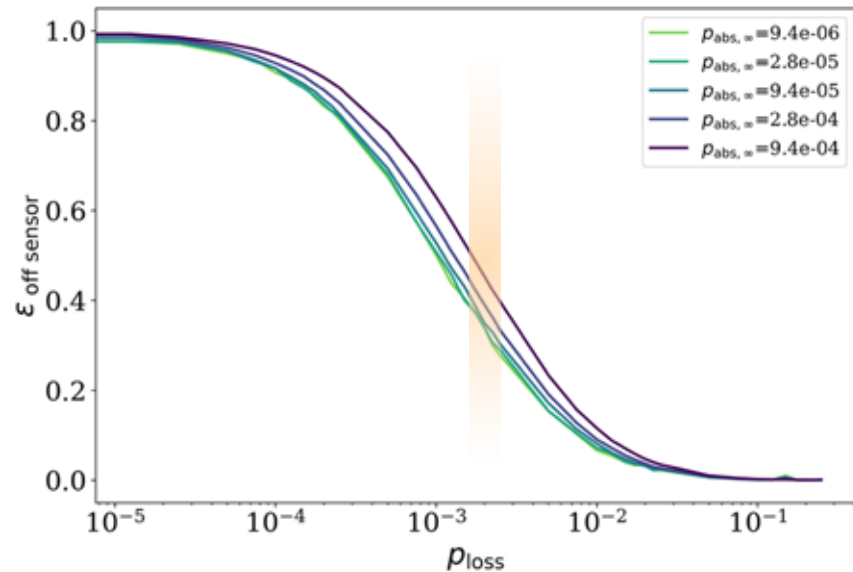
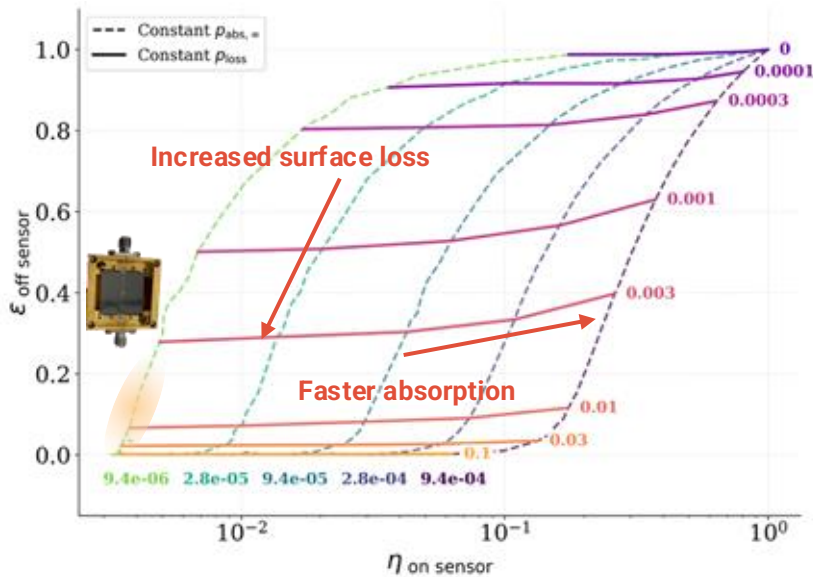


$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0.1
$P_{\text{abs, Cu}}$	0
$P_{\text{abs, polished surfaces}}$	0.002
$P_{\text{abs, side walls}}$	0

η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

Parameter Space for Low Coverage

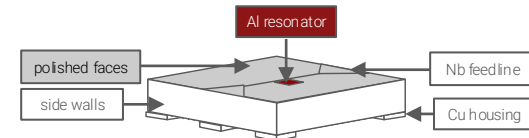
Assuming isotropic phonon loss, position dependence is a good indicator for loss probability.



η : absolute phonon energy collection efficiency

ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{max}$

$\rho_{abs,\infty}$: absorption probability at interface $\times$ area coverage fraction



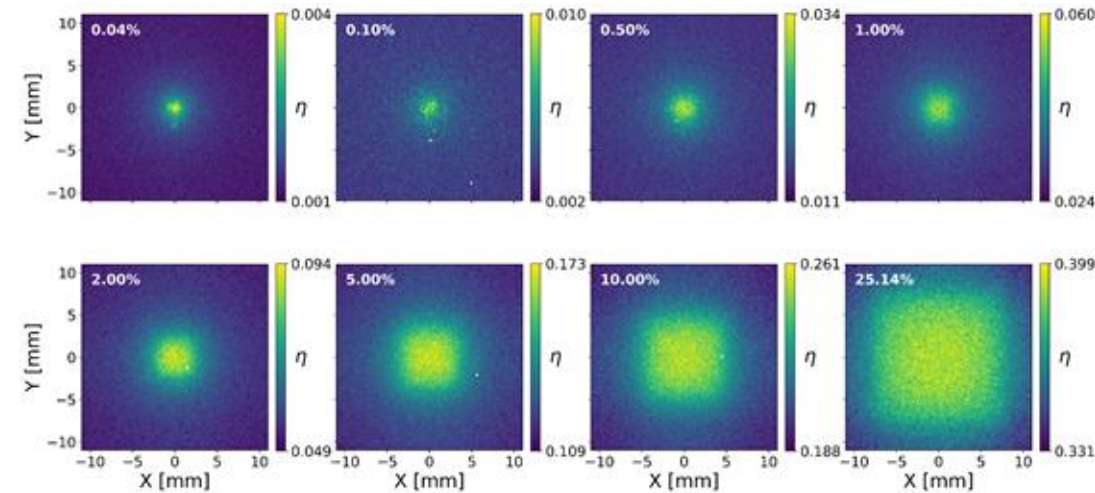
Part II

Impact of Phonon Loss on Forward Modeling

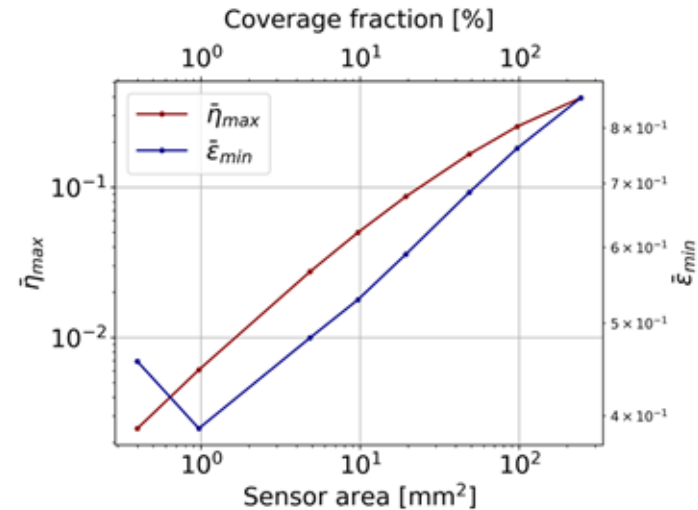
Varying Sensor Area



Assuming isotropic phonon loss, we can map out how different phonon sensor layouts perform.



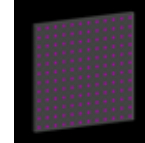
η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\max}$



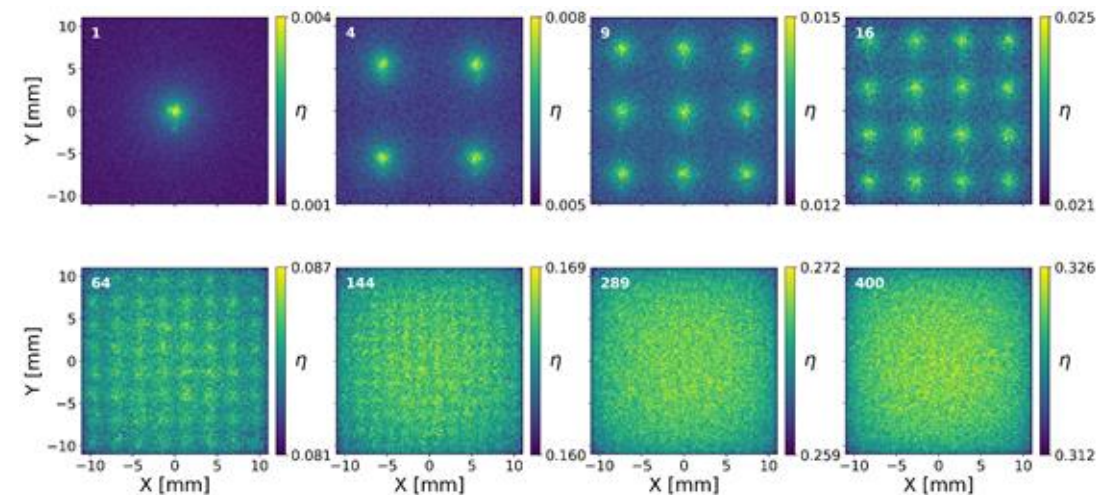
$\bar{\eta}$: average $\eta(x,y)$ above 2σ

$\bar{\epsilon}$: $\frac{\text{average } \eta(x,y) \text{ below } 2\sigma}{\text{average } \eta(x,y) \text{ above } 2\sigma}$

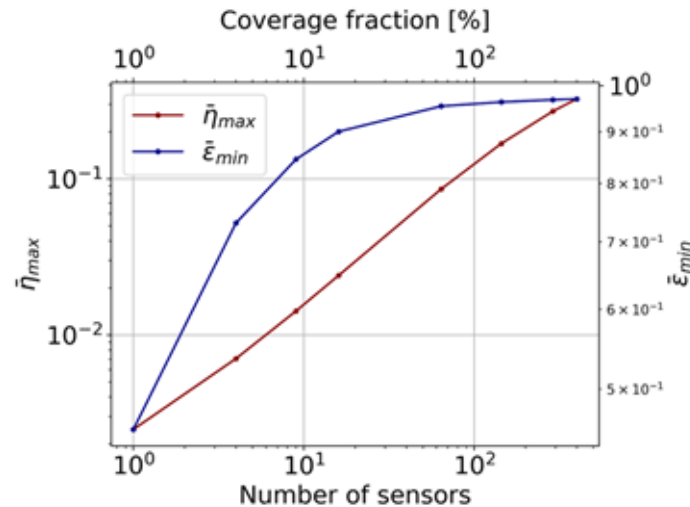
Varying Number of Sensors



Assuming isotropic phonon loss, we can map out how different phonon sensor layouts perform.



η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\max}$



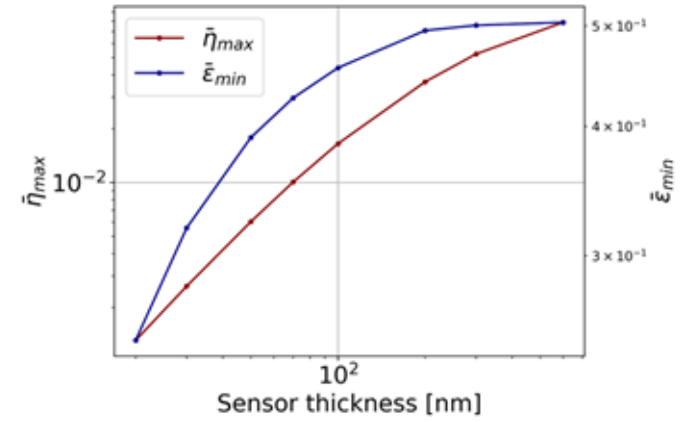
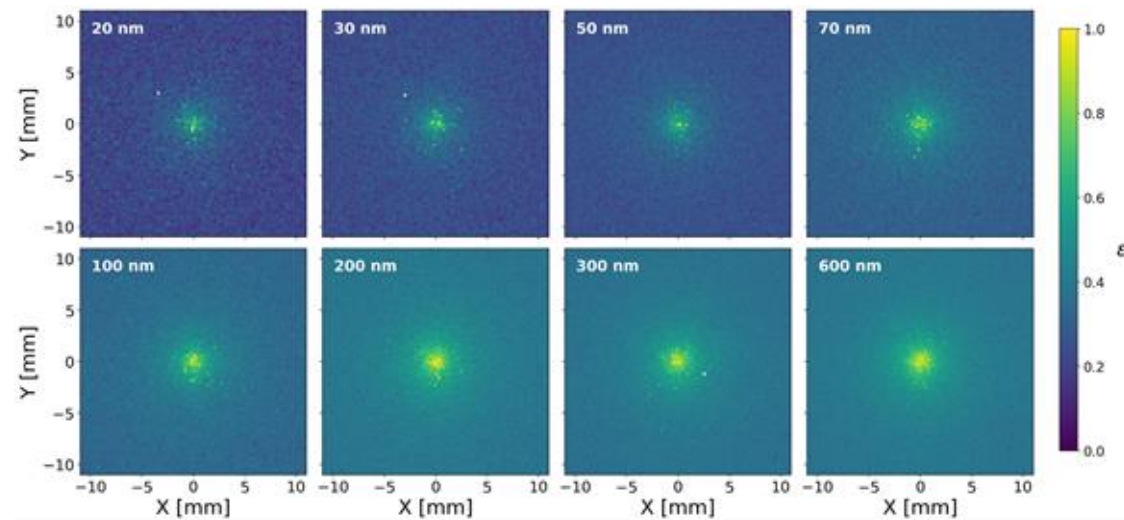
$\bar{\eta}$: average $\eta(x,y)$ above 2σ

$\bar{\epsilon}$: $\frac{\text{average } \eta(x,y) \text{ below } 2\sigma}{\text{average } \eta(x,y) \text{ above } 2\sigma}$

Varying Sensor Film Thickness



Assuming isotropic phonon loss, we can map out how different phonon sensor layouts perform.



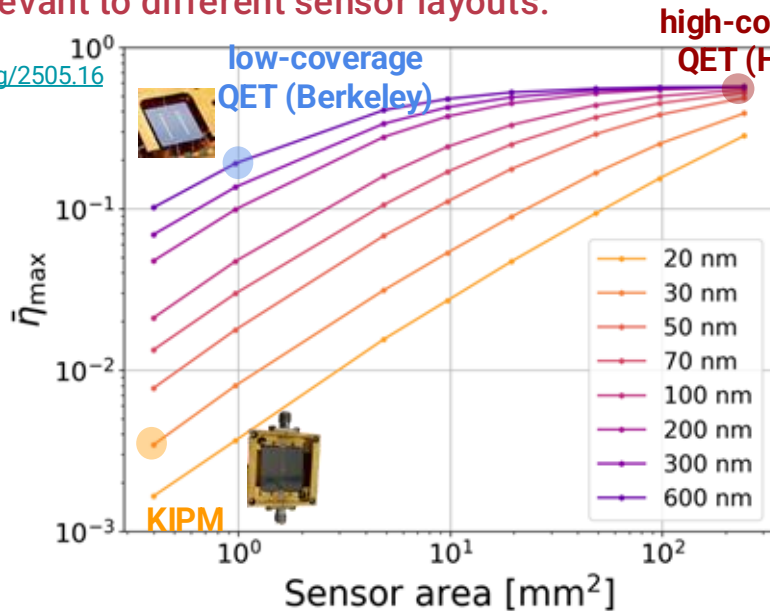
η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{max}$

$\bar{\eta}$: average $\eta(x,y)$ above 2σ
 $\bar{\epsilon}$: $\frac{\text{average } \eta(x,y) \text{ below } 2\sigma}{\text{average } \eta(x,y) \text{ above } 2\sigma}$

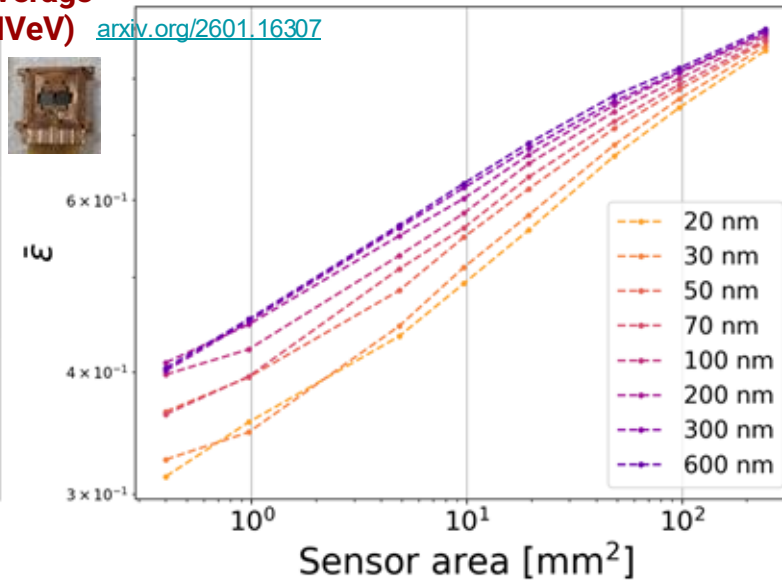
Parameter Space Beyond Low Coverage

From our assumptions of phonon loss, we can create a "lookup table" for the optimization space relevant to different sensor layouts.

arxiv.org/2505.16092v1



arxiv.org/2601.16307

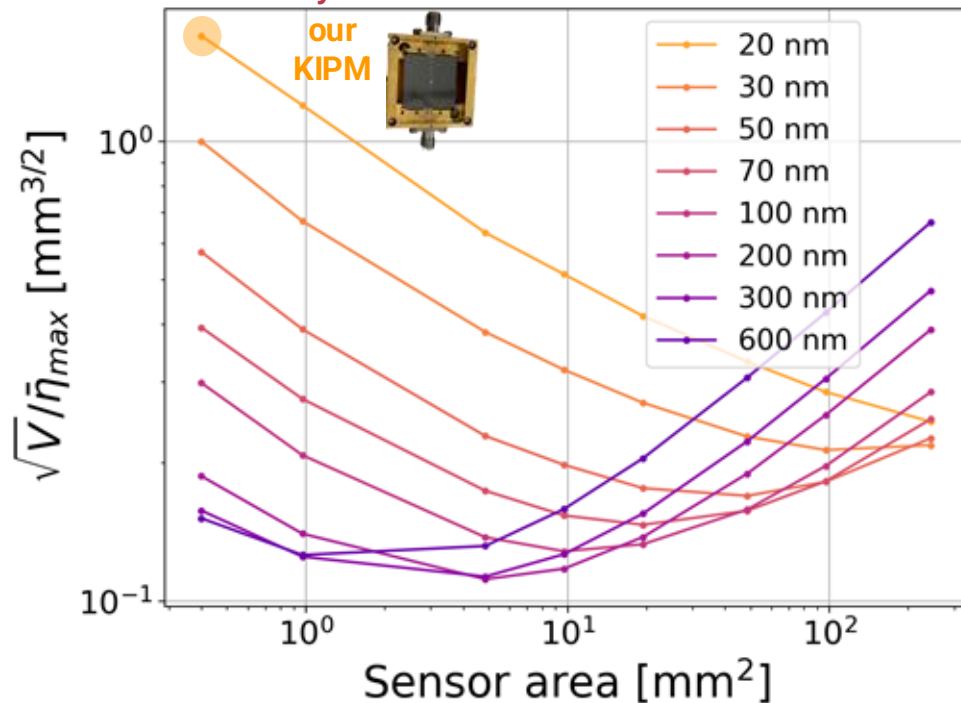


η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\max}$

$\bar{\eta}$: average $\eta(x,y)$ above 2σ
 $\bar{\epsilon}$: $\frac{\text{average } \eta(x,y) \text{ below } 2\sigma}{\text{average } \eta(x,y) \text{ above } 2\sigma}$

Direct Absorber Volume Optimization

We explore the volume optimization for direct absorber phonon sensors as a trade off between collection efficiency and sensor resolution.



The ideal calorimeter, without any trapping enhancement, will have resolution scale as the square root of absorber volume.

$$\sigma_E^{\text{abs}} \propto \sqrt{V_{\text{ind}}}$$

$$\sigma_E \propto \frac{\sigma_E^{\text{abs}}}{\eta_{\text{ph}}}$$

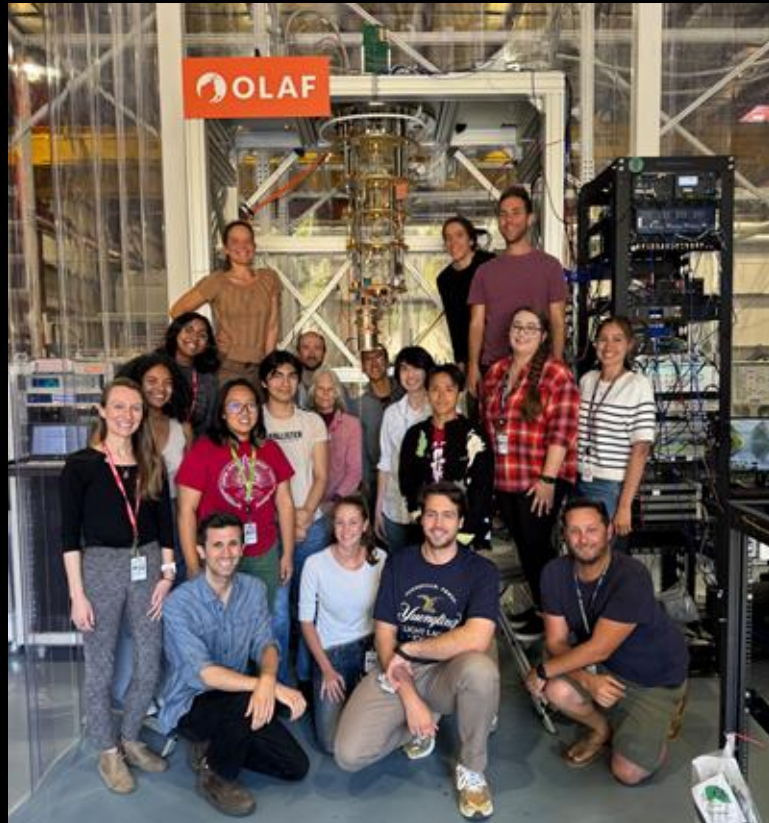
η : absolute phonon energy collection efficiency
 $\bar{\eta}$: average $\eta(x,y)$ above 2σ

Conclusion

Benchmarking effects of phonon loss is relevant for modeling diverse phonon sensors in G4CMP.

- Our MEMS measurement of position-dependent phonon responsivity provides a benchmark for phonon loss, which we think is isotropic & potentially at crystal surfaces
- Assuming this isotropic loss, we can project efficiency for different sensor layouts
- Next steps: given models of sensor resolution, we can make sensitivity projections for different sensor layouts and architectures

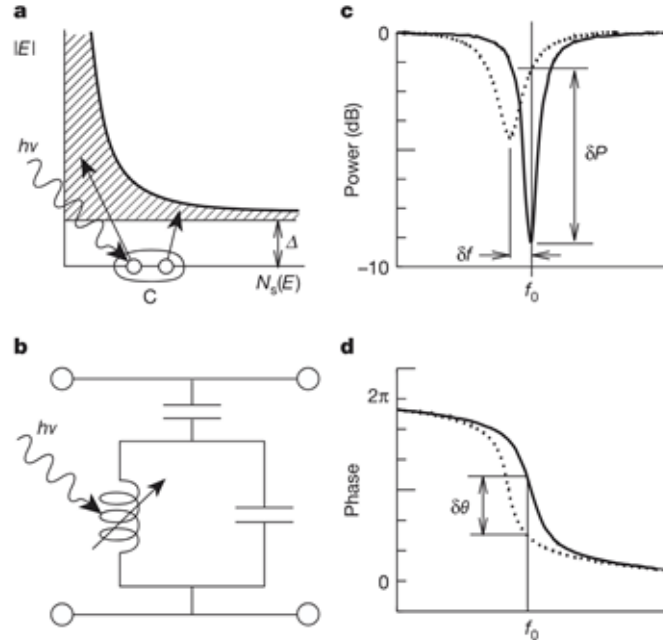
Thank you!



Backup

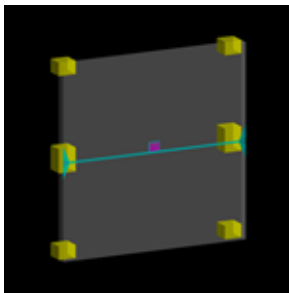
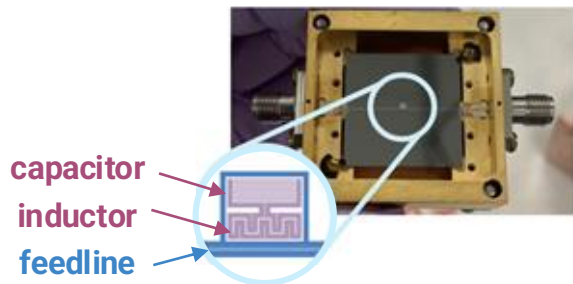
Microwave Kinetic Inductance Detectors

Quasiparticles from broken Cooper pairs shift kinetic inductance in a superconducting resonator.



<https://doi.org/10.7907/GZ72-V784>

Kinetic Inductance Phonon-Mediated Detectors



Our KIPM (OW230427)

1mm x 2cm x 2cm Si chip
30 nm Al resonator, 70 nm Nb feedline
0.09% sensor surface area coverage
<13,695.6 μm^3 active inductor volume
Fabricated at JPL by Osmond Wen and Bruce Bumble

- Use cases: low-threshold rare event searches, co-sensors for qubits
- Overall detector resolution is limited by low phonon collection efficiency

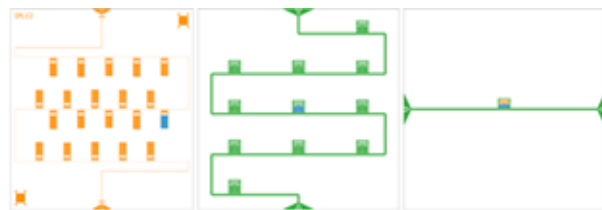
$$\sigma_E = \frac{\sqrt{N_r}}{\eta_{\text{ph}}} \sigma_E^{\text{abs}}$$

number of resonators $\downarrow$

resolution on energy deposited in the substrate (hundreds of eV) $\rightarrow$

resolution on energy absorbed by the sensor (few eV) $\leftarrow$

phonon collection efficiency (<1%) $\uparrow$

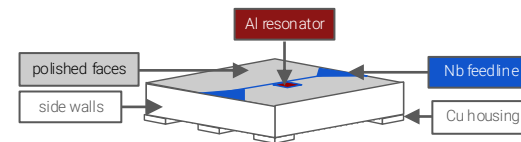
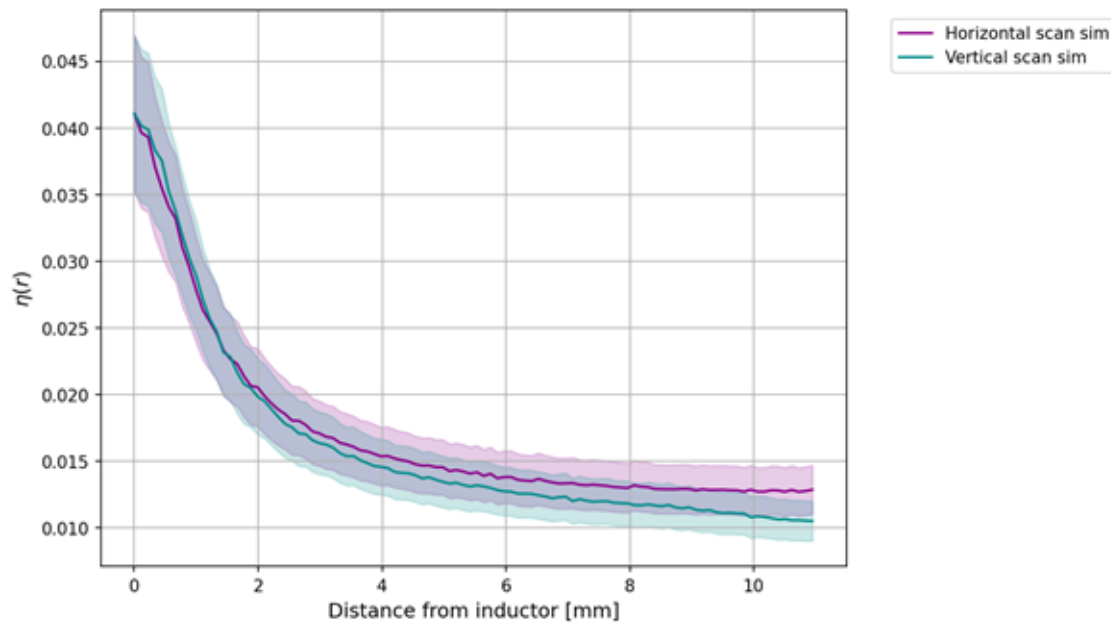


σ_{Edep} [eV]	380	320	850
σ_{Eabs} [eV]	5.9 ± 0.9	2.1 ± 0.1	23
η [%]	7.0 ± 1.1	0.78 ± 0.07	1.1 ± 0.2

Note on Parameters for Part I

- Studies in Part I do not model quasiparticles using either KaplanQP or TrackedFilmResponse
 - Any above-gap phonons that are absorbed according to the phonon absorption probability are counted toward energy depositions
- Other relevant parameters:
 - For slides 6-12, electron-hole pairs are generated in a uniform (x,y) distribution across the L-scan region & an exponential z distribution consistent with the attenuation of a 625-nm optical photon in Si
 - For slide 13, electron-hole pairs are generated at the center of the inductor for the "on-sensor" (x,y) position and (-9.3 mm, 8.52 mm) for the "off-sensor" (x,y) position; the z position is still sampled from the exponential distribution
 - Electron-hole pairs each have a 0.814-eV kinetic energy partitioned in an "all-to-one" scheme to electron or hole
 - Charge trapping is off
 - Maximum phonon bounces = 100000

$\eta(r)$ in Part I



$P_{\text{abs, inductor}}$	0.103
$P_{\text{abs, capacitor}}$	0
$P_{\text{abs, Nb}}$	0.1
$P_{\text{abs, Cu}}$	0
$P_{\text{abs, polished surfaces}}$	0.002
$P_{\text{abs, side walls}}$	0

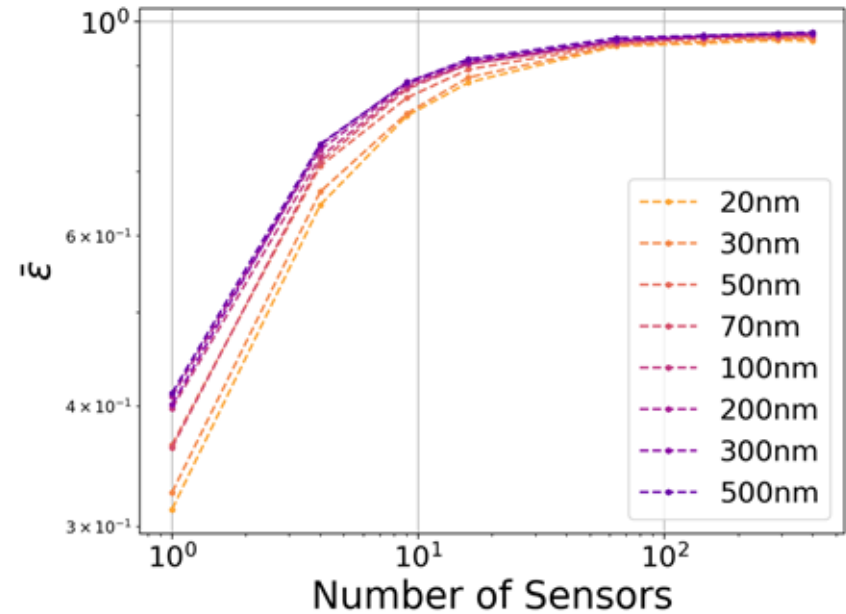
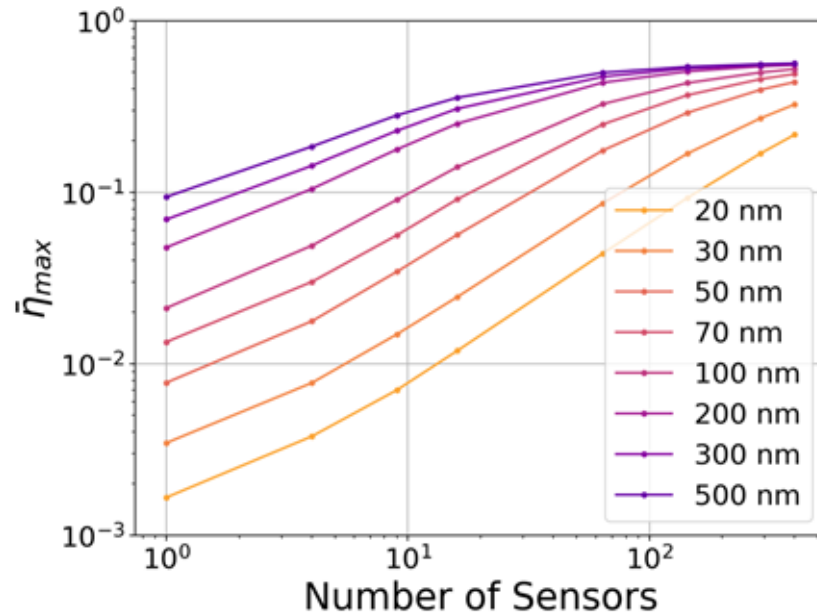
η : absolute phonon energy collection efficiency

ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{\text{max}}$

Note on Parameters for Part II

- Studies in Part II model quasiparticles in 0D using KaplanQP
 - Phonon transmission probability: $p_{\text{trans, Si} \rightarrow \text{Al}} = 0.795^*$
 - Pairbreaking probability: $p_{\text{break}} = 1 - \exp(-4d/\lambda_{\text{pb}})$
 - d = sensor film thickness, λ_{pb} = pairbreaking length $\approx 866 \text{ nm}^*$
 - filmAbsorption: $p_{\text{abs}} = p_{\text{trans}} \times p_{\text{break}}$
- Other relevant parameters:
 - For slides 15-17, electron-hole pairs are generated in a uniform (x,y) distribution and an exponential z distribution consistent with the attenuation of a 625-nm optical photon in Si
 - For slides 18-19, electron-hole pairs are generated in a diagonal (x,y) distribution from (0 mm, 0 mm) to (11 mm, 11 mm) and an exponential z distribution
 - Electron-hole pairs each have a 0.814-eV kinetic energy partitioned in an "all-to-one" scheme to electron or hole
 - Charge trapping is off
 - Maximum phonon bounces = 100000

More Sensor Layout Studies

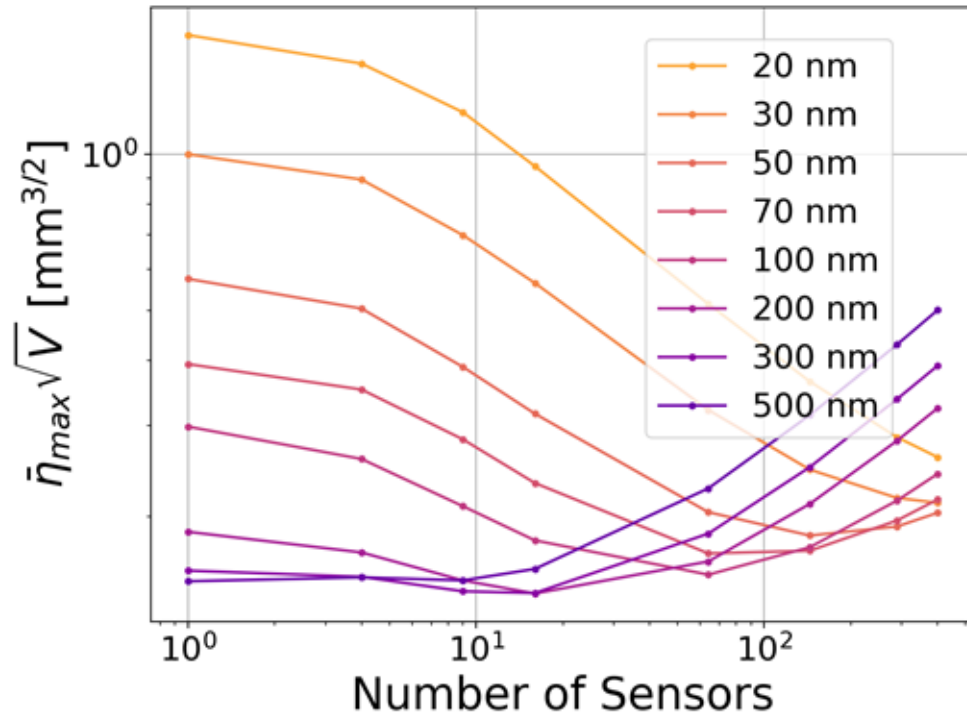


η : absolute phonon energy collection efficiency
 ϵ : relative phonon energy collection efficiency; $\epsilon(x,y) = \eta(x,y) / \eta_{max}$

$\bar{\eta}$: average $\eta(x,y)$ above 2σ

$\bar{\epsilon}$: $\frac{\text{average } \eta(x,y) \text{ below } 2\sigma}{\text{average } \eta(x,y) \text{ above } 2\sigma}$

More Sensor Layout Studies



η : absolute phonon energy collection efficiency
 $\bar{\eta}$: average $\eta(x,y)$ above 2σ

Volume Scaling of an Ideal Calorimeter

Temperature evolution, in the limit of mapping sensor response to equilibrium temperature state:

$$C(T) \frac{dT}{dt} = -K [T_{film}^5 - T_{bath}^5]$$

Linearize first term & assume film thermalizes in steady state, we get $\frac{dT}{dt} = -\frac{G(T)}{C(T)} \Delta T = -\frac{\Delta T}{\tau(T)}$

Solution with initial $\Delta T = E/C$: $\Delta T = \frac{E}{C(T)} \exp(-t/\tau(T)) \Theta(t) \rightarrow \text{pulse amplitude} \propto \text{energy deposited}$

Power signal from fluctuation-dissipation theorem: $P_{sig} = G(T) \Delta T(t) = \frac{\eta E}{\tau} \exp(-t/\tau(T)) \Theta(t) = ES(t)$

Noise in Fourier space: $P_N^2(f) = 4k_b T^2 G f_{link}$

Energy resolution:
$$\begin{aligned} \sigma_E^2 &= \left[4 \int_0^\infty \frac{s(f)^2}{P_N^2(f)} df \right]^{-1} \\ &= k_b T^2 G f_{link} \left[\int_0^\infty s(f)^2 df \right]^{-1} \\ &\geq \frac{4k_b T^2 C f_{link}}{\eta^2} \end{aligned}$$

In the limit that $C = c_{VT} VT$, where C_{VT} is the volumetric specific heat:

$$\sigma_E^2 \geq \frac{2k_b T^3 V c_{VT}}{\eta^2} \rightarrow \sigma_E \geq \frac{\sqrt{2k_b VT} T^{3/2}}{\eta}$$